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MS: AF
RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURES EXAMINING
GROUP 1765

PATENT
3430-0140P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	AHN, Byung-Yong	Conf.:	3449
Appl. No.:	09/747,928	Group:	1765
Filed:	December 27, 2000	Examiner:	B. Tran
For:	DRY ETCHING METHOD AND APPARATUS FOR USE IN THE LCD DEVICE		

AMENDMENT UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 16, 2004

Sir:

In response to the final Office Action dated May 17, 2004, the following amendment and remarks are respectfully submitted in connection with the above-identified application.

This Reply includes Amendments to the Claims and Remarks.